

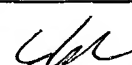




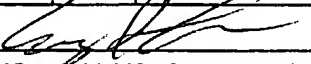




U.S. Department of Commerce, Patent and Trademark Office					Atty Docket No.		Serial No.	
					KUO-P102-1C		Not yet assigned	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT					Applicant(s)			
(Use several sheets if necessary)					Yee-Chung Fu			
					Filing Date		Group	
					Herewith		Not yet assigned	
U.S. Patent Documents								
*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate	
<i>SpL</i>	AA	6,155,490	12/5/00	Ackley	235	472.01		
<i>GM</i>	AB	6,088,145	7/11/00	Dickensheets et al.	359	196		
	AC							
	AD							
	AE							
	AF							
	AG							
	AH							
	AI							
	AJ							
	AK							
Foreign Patent Documents								
							Translation	
		Document	Date	Country	Class	Subclass	Yes	No
	AL							
	AM							
	AN							
	AO							
	AP							
OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)								
<i>SpL</i>	AQ	Robert A. Conant et al., "A Flat High-Frequency Scanning Micromirror", Berkeley Sensor & Actuator Center, University of California, Berkeley, Berkeley, CA, 4 pages.						
<i>SpL</i>	AR	Harald Schenk et al., "Large Deflection Micromechanical Scanning Mirrors for Linear Scans and Pattern Generation", IEEE Journal of Selected Topics in Quantum Electronics, Vol. 6, No. 5, September/October 2000, pp 715-721.						
<i>SpL</i>	AS	Pamela R. Patterson et al., "A Scanning Micromirror With angular Comb Drive Actuation", Electrical engineering Department, University of California at Los Angeles, Los Angeles, CA; Institute of Industrial Science, University of Tokyo, Tokyo, Japan, pp 544-547.						
Examiner		<i>SpL</i>						
Date Considered		4/13/04						
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with your communication to applicant.								

U.S. Department of Commerce, Patent and Trademark Office				Atty Docket No.		Serial No.		
				KUO-P100		Not yet assigned		
INFORMATION DISCLOSURE STATEMENT BY APPLICANT				Applicant(s)				
(Use several sheets if necessary)				Ting-Tung Kuo				
				Filing Date		Group		
				Herewith		Not yet assigned		
U.S. Patent Documents								
*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate	
	AA							
	AB							
	AC							
	AD							
	AE							
	AF							
	AG							
	AH							
	AI							
	AJ							
	AK							
Foreign Patent Documents								
							Translation	
		Document	Date	Country	Class	Subclass	Yes	No
	AL							
	AM							
	AN							
	AO							
	AP							
OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)								
	AQ	Meng-Hsiung Kiang et al., "Micromachined Polysilicon Microscanners for Barcod Readers", IEEE Photonics Technology Letters, Vol. 8, No. 12, December 1996, pp 1707-1709.						
	AR	Osamu Tsuboi et al., "A Rotational Comb-Driven Micromirror With A Large Deflection Angle And Low Drive Voltage", Fujitsu Laboratories Ltd., pp 532-535.						
	AS	Hiroshi Miyajima et al., "Product Development Of A Mems Optical Scanner For A Laser Scanning Microscope", Olympus Optical Co., Ltd., Tokyo, Japan, pp 552-555.						
Examiner 		Date Considered 4/13/04						
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with your communication to applicant.								

U.S. Department of Commerce, Patent and Trademark Office				Atty Docket No.		Serial No.		
				KUO-P100		Not yet assigned		
INFORMATION DISCLOSURE STATEMENT BY APPLICANT				Applicant(s)				
(Use several sheets if necessary)				Ting-Tung Kuo				
				Filing Date		Group		
				Herewith		Not yet assigned		
U.S. Patent Documents								
*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate	
	AA							
	AB							
	AC							
	AD							
	AE							
	AF							
	AG							
	AH							
	AI							
	AJ							
	AK							
Foreign Patent Documents								
							Translation	
		Document	Date	Country	Class	Subclass	Yes	No
	AL							
	AM							
	AN							
	AO							
	AP							
OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)								
	AQ	Jin-Ho Lee et al., "Design And Fabrication Of Scanning Mirror For Laser Display", 2002 Elsevier Science B.V., pp 223-230.						
	AR	Clark T.-C Nguyen, "Frequency-Selective MEMS for Miniaturized Communications Devices", 1998 IEEE, Department of Electrical Engineering and Computer Science University of Michigan, pp 445-460.						
	AS	Faiz Sherman et al., "In-Plane Microactuator For fluid Control Application", Electrical Engineering Department University of California, Los Angeles, 6 pages.						
Examiner 		Date Considered 4/13/04						
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with your communication to applicant.								

U.S. Department of Commerce, Patent and Trademark Office				Atty Docket No.		Serial No.	
				KUO-P100		Not yet assigned	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT				Applicant(s)			
(Use several sheets if necessary)				Ting-Tung Kuo			
				Filing Date		Group	
				Herewith		Not yet assigned	
U.S. Patent Documents							
*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						
Foreign Patent Documents							
						Translation	
		Document	Date	Country	Class	Subclass	Yes No
	AL						
	AM						
	AN						
	AO						
	AP						
OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)							
	AQ	D. Lee et al., "High-Resolution, High-Speed Microscanner In Single-Crystalline Silicon Actuated By Self-Aligned Dual-Mode Vertical Electrostatic Combedrive With Capability For Phased Array Operation", IEEE, The 12 th International Conference on Solid State Sensors, Actuators and Microsystems, Boston, June 8-12, 2003, pp 576-579.					
	AR						
	AS						
Examiner 		Date Considered 4/13/04					
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with your communication to applicant.							